

Fig.1
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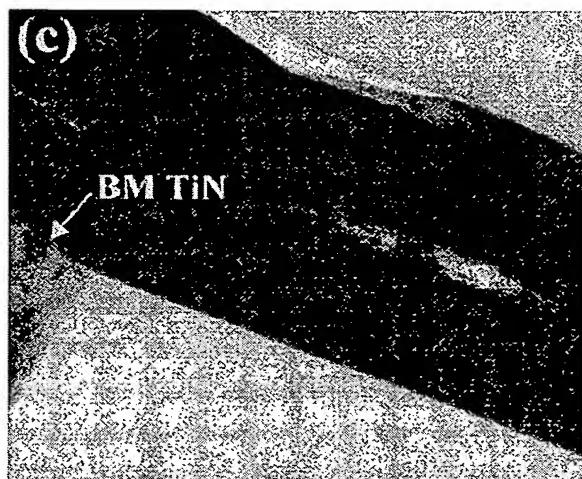


Fig.2
<Prior Art>

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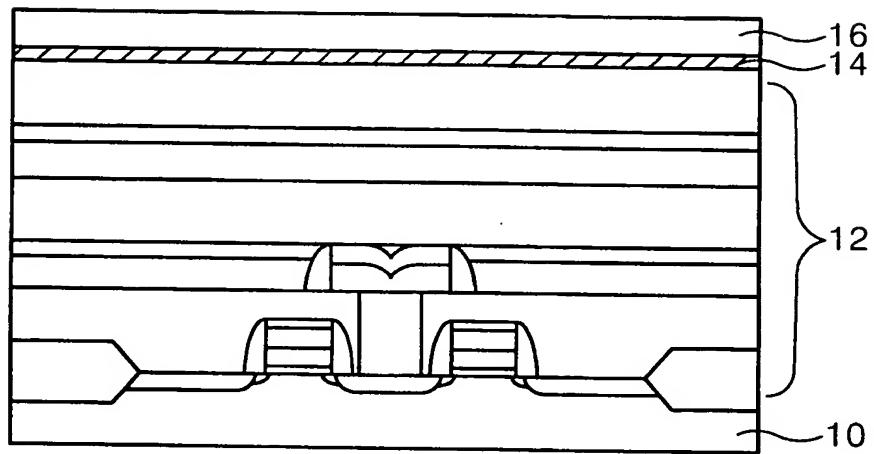


Fig.3a

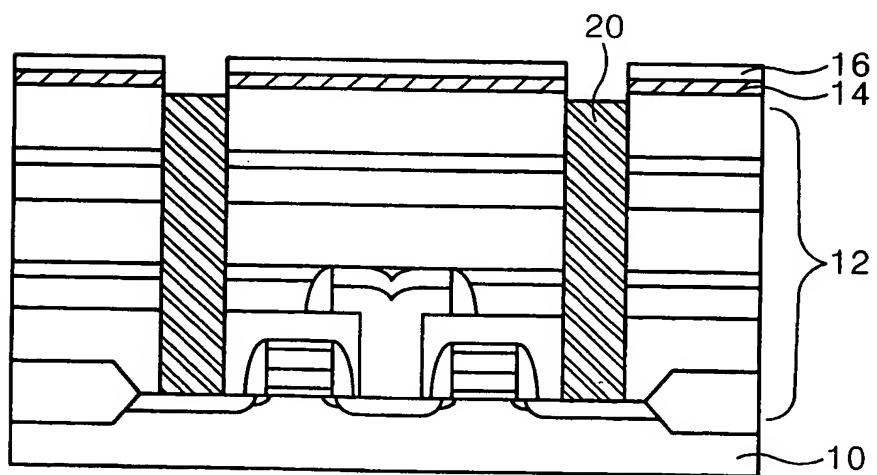


Fig.3b

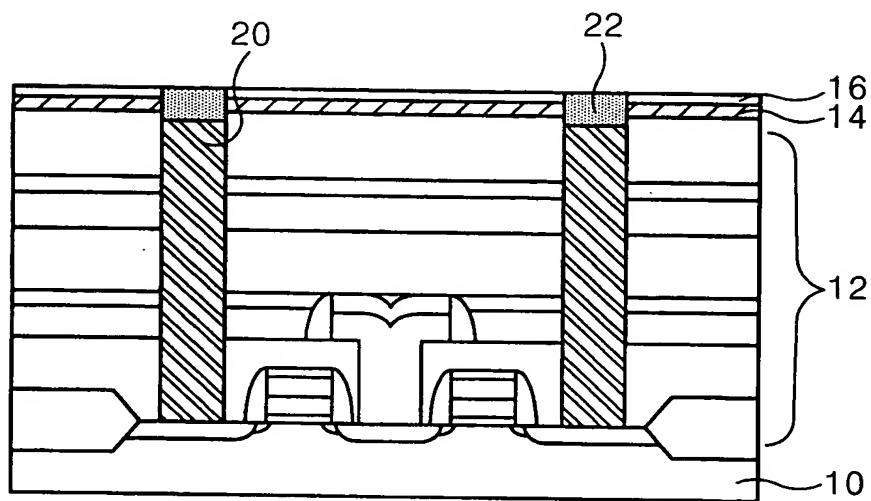


Fig.3c

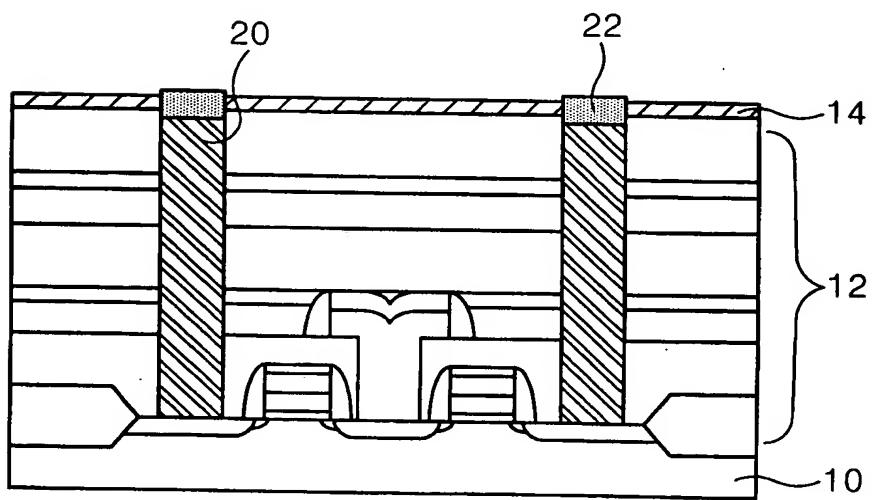


Fig.3d

Jong Han SHIN et al.
"Method for Manufacturing Capacitor
of Semiconductor Device"
Attorney Docket No. 40296-0040

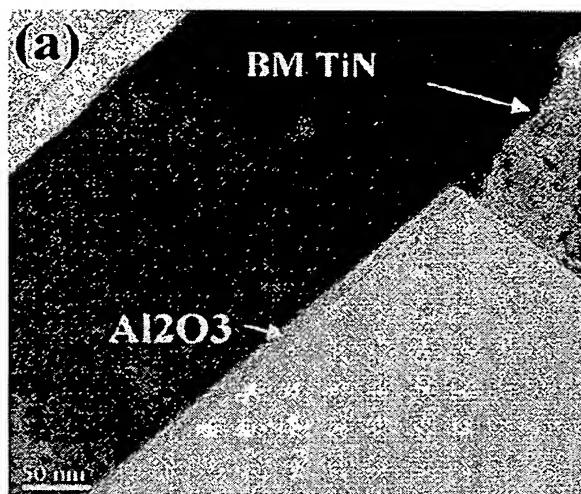


Fig.4

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